INFORMATION DISCLOSURE CITATION *(Use several sheets if necessary)*	Docket Number (Optional) BUR920030135US1	Application Number 10/709292 ~~Not Yet Assigned~~
	Applicant(s) Allen et al.	
	Filing Date 04/27/04 ~~Concurrently Herewith~~	Group Art Unit Unknown

*EXAMINER INITIAL		OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*
		Papadopoulou, E. and Lee, D.T., "Critical area computation via Voronoi diagrams," Computer-Aided Design of Integrated Circuits and Systems, IEEE Transactions on , Vol. 18, No. 4, pp .463-474, April 1999.
NL		Papadopoulou, E., "Critical area computation for missing material defects in VLSI circuits ," Computer-Aided Design of Integrated Circuits and Systems, IEEE Transactions on , Vol. 20, No. 5, pp 583-597, May 2001.
NL		Fook-Luen Heng and Zhan Chen. "VLSI Yield Enhancement Techniques Through Layout Modification." IBM T. J. Watson Research Center, pp. 1-15, July 17, 2000.
NL		A. Venkataraman and I. Koren. "Trade-offs between Yield and Reliability Enhancement." Proc. of the 1996 IEEE National Symposium on Defect and Fault Tolerance in VLSI Systems, pp. 67-75, November 1996.

EXAMINER Nelson Lam	DATE CONSIDERED 8/29/06

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	INTEGRATED CIRCUIT YIELD ENHANCEMENT USING VORONOI DIAGRAMS

Application Number :

Confirmation Number:

First Named Applicant: Robert Allen

Attorney Docket Number: BUR920030135US1

Art Unit:

Examiner:

Search string: (6178539 or 6247853 or 6317859).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
NL	1	6178539	2001-01-23	Papadopoulou et al.			
NL	2	6247853	2001-06-19	Papadopoulou et al.			
NL	3	6317859	2001-11-13	Papadopoulou et al.			

Signature

Examiner Name	Date
Nelson Lam	8/29/06